

## United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/967,094 09/28/2001		Siddhartha Bhowmik	Bhowmik 12-146-1/075903-3	7197	
29391	7590 04/14/2005		EXAMINER		
	ROWNLEE WOLTER ORANGE AVENUE	ERDEM, FAZLI			
SUITE 2500	· · · · · · · · · · · · · · · · · · ·	ART UNIT	PAPER NUMBER		
ORLANDO, FL 32801			2826		
			DATE MAILED: 04/14/200	S	

Please find below and/or attached an Office communication concerning this application or proceeding.

		A		4					
		Application		Applicant(s)	(En				
Office Action Summary		09/967,09		BHOWMIK ET AL.	(2)				
	Omce Action Summary	Examiner		Art Unit					
		Fazli Erde		2826					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply									
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).									
Status	•		·						
1)🖂	Responsive to communication(s) filed o	n 25 March 2005.							
		$\boxtimes$ This action is n	on-final.						
3)									
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims									
4)[🛛	Claim(s) 1 3-7 9 10 12-17 and 19 is/are	nending in the an	nlication						
	P) Claim(s) 1,3-7,9,10,12-17 and 19 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.								
_	5)⊠ Claim(s) <u>1,3-7,9,12-17 and 19</u> is/are allowed.								
	⊠ Claim(s) <u>10</u> is/are rejected.								
· —									
'	Claim(s) are subject to restriction and/or election requirement.								
Applicati	ion Papers								
9)□	The specification is objected to by the Fa	xaminer							
9)∐ The specification is objected to by the Examiner.  10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.									
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).									
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.05(a).									
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.									
Priority ι	ınder 35 U.S.C. § 119								
12)☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).									
a) ☐ All b) ☐ Some * c) ☐ None of:									
1.☐ Certified copies of the priority documents have been received.									
2. Certified copies of the priority documents have been received in Application No									
	3. Copies of the certified copies of the				ge				
	application from the International				•				
* See the attached detailed Office action for a list of the certified copies not received.									
Amarka	V-1								
Attachment	t(s) e of References Cited (PTO-892)		4) Interview Summeru	(DTO 442)					
2) Notic	e of Draftsperson's Patent Drawing Review (PTO-9	948)	4) Interview Summary ( Paper No(s)/Mail Da	te					
3) 💢 Inform Pape	nation Disclosure Statement(s) (PTO-1449 or PTO r No(s)/Mail Date <u>のけ</u> み)。 - No(s)/Mail Date	/SB/08)	5) Notice of Informal Pa	atent Application (PTO-152	<u>'</u>				

Application/Control Number: 09/967,094 Page 2

Art Unit: 2826

## **DETAILED ACTION**

## Allowable Subject Matter

1. Claims 1, 3-7,9, 12-17 and 19 allowed.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claim 10 rejected under 35 U.S.C. 103(a) as being unpatentable over Kobayashi et al. (JP 64-064318) in view of Cadien et al. (5,604,158) further in view of Nishida (4,927,786).

Regarding Claim 10, Kobayashi et al. disclose a manufacturing method of semiconductor device where in substrate 1, tungsten silicide film 5 and tungsten film 6 and electrode 7 of aluminum. Kobayashi et al. fail to disclose the tungsten plug and the required deposition chamber/tungsten coil. However, Cadient et al disclose an integrated tungsten/tungsten silicide plug process where in Fig. 3c tungsten plug is labeled as 308. Furthermore, Nishida et al. disclose a process for semiconductor device manufacture where in Fig. 4, 403 is tungsten coil and 406 is deposition chamber.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required tungsten plug and deposition chamber/tungsten coil in Kobayashi et al. as taught by Cadien et al. and Nishida, in order to have a semiconductor device with increased reliability.

Application/Control Number: 09/967,094

Art Unit: 2826

Conclusion

Page 3

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Fazli Erdem whose telephone number is (571) 272-1914. The

examiner can normally be reached on M - F 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Nathan Flynn can be reached on (571) 272-1915. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

FE

April 8, 2005

NATHAN J FLYNN SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800